

	U	1	Document ID	Issue Date	Pages	Title	Current OR
1	<input type="checkbox"/>	<input type="checkbox"/>	US 6521966 B1	20030218	11	Semiconductor strain sensor	257/417
2	<input type="checkbox"/>	<input type="checkbox"/>	US 5394751 A	19950307	10	Method of producing semiconductor pressure sensor	73/756
3	<input type="checkbox"/>	<input type="checkbox"/>	US 5225373 A	19930706	21	Method of manufacturing semiconductor pressure sensor device with two semiconductor pressure sensor chips	438/51
4	<input type="checkbox"/>	<input type="checkbox"/>	US 5126813 A	19920630	21	Semiconductor pressure sensor device with two semiconductor pressure sensor chips and a method of manufacturing thereof	257/417
5	<input type="checkbox"/>	<input type="checkbox"/>	JP 05107264 A	19930427	4	Semiconductor acceleration sensor - having strain gauge resistor on diaphragm in sensor chip bonded to die pad of lead frame NoAbstract	

	Current XRef	Retrieval Classif	Inventor	S	C	P	2	3	4	5
1	257/418; 257/419		Ishio, Seiichiro et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
2	257/676; 257/696		Ishibashi, Kiyoshi	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
3	257/E23.05 5; 29/621.1; 29/827; 438/118		Takahashi, Yoshiharu et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
4	257/783; 257/E23.05 5		Takahashi, Yoshiharu et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
5				<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>

	Image Doc. Displayed	PT
1	US 6521966	<input type="checkbox"/>
2	US 5394751	<input type="checkbox"/>
3	US 5225373	<input type="checkbox"/>
4	US 5126813	<input type="checkbox"/>
5	JP 05107264 A	<input type="checkbox"/>

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L10	0	sensor and "lead frame" and (gage gauge) adj resistor and medium near3 pressure	USPAT; US-PGPUB; DERWENT	2004/11/08 11:21	
2	BRS	L11	2147	sensor and "lead frame"	USPAT; US-PGPUB; DERWENT	2004/11/08 11:22	
3	BRS	L12	2546	11 (gage gauge) adj resistor	USPAT; US-PGPUB; DERWENT	2004/11/08 11:21	
4	BRS	L14	334	sensor and "lead frame" and power adj supply	USPAT; US-PGPUB; DERWENT	2004/11/08 11:23	
5	BRS	L15	0	13 and 14	USPAT; US-PGPUB; DERWENT	2004/11/08 11:22	
6	BRS	L13	5	11 and (gage gauge) adj resistor	USPAT; US-PGPUB; DERWENT	2004/11/08 11:23	
7	BRS	L17	0	13 and control\$3 adj (device element)	USPAT; US-PGPUB; DERWENT	2004/11/08 11:24	

	Error Definition	Er ro rs
1		0
2		0
3		0
4		0
5		0
6		0
7		0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
8	BRS	L16	28	14 and control\$3 adj (device element)	USPAT; US-P GPUB ; DERW ENT	2004/11/08 11:29	

	Error Definition	Er ro rs
8		0